

Notice of References Cited	Application/Control No. 09/779,440	Applicant(s)/Patent Under Reexamination SHIOMI ET AL.	
	Examiner Jung W. Kim	Art Unit 2132	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Collberg et al.; "Manufacturing Cheap, Resilient, and Stealthy Opaque Constructs"; January 1998; Annual Symposium on Principles of Programming Languages; pp. 184-196, http://citeseer.ist.psu.edu/collberg98manufacturing.html .
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